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PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Takayuki YAGI et al.

Application No.: 09/819,672

Filed: March 29, 2001

For: ELECTRON OPTICAL SYSTEM ARRAY,  
 CHARGED-PARTICLE BEAM EXPOSURE  
 APPARATUS USING THE SAME, AND  
 DEVICE MANUFACTURING METHOD

Examiner: K. Nguyen

Group Art Unit: 2881

Confirmation No.: 3159

December 22, 2003

Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

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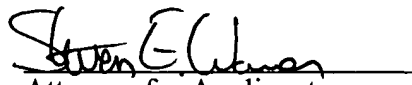
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Sir:

Please permit C.T. Tran of FITZPATRICK, CELLA, HARPER & SCINTO to inspect and make copies of any and all papers in the Patent and Trademark Office file of the above-identified application.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
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